ocket No. 0756-1998



In re Patent Application of ) Shunpei YAMAZAKI et al. ) Serial No. 09/352,194 Filed: July 13, 1999-For: CRYSTALLINE SEMICONDUCTOR ) THIN FILM, METHOD OF FABRICATING THE SAME SEMICONDUCTOR DEVICE, AND ) METHOD OF FABRICATING THE ) SAME

Art Unit: 2823 Examiner: Fernando L. Toledo

## CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with The United States Postal Service with sufficient stage as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on \_

## **INFORMATION DISCLOSURE STATEMENT**

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Commissioner for Patents Washington, DC 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, Applicant submits herewith attached Form PTO-1449 listing references known to Applicant and requests that these references be made of record in the above identified application. Copies of the references listed are submitted herewith in accordance with 37 C.F.R. It is requested that the accompanying information disclosure statement be considered and made of record in the above-captioned application. To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that the Examiner initial a copy of this form and return to the undersigned.

The references listed on the attached form PTO-1449 were cited in an Office Action dated April 24, 2002 in family Application Serial No. 09/894,125. The '125 application and the subject application share Japanese Priority Document No. 10-203205.

Application No. 09/352,194 Docket No. 0756-1998

A Request for Continued Examination was filed on April 24, 2002 and no further Action has been received from the Patent Office. Therefore, no fee is required.

Respectfully submitted,

Eric J. Robinson

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